

10/772,132

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Remarks

Applicant notes with appreciation the Examiner's indication that claims 1, 3, 4 and 5/1 are allowable.

The Examiner's rejection of claims 2 and 5/2 is based on the Jeng patent, which shows a plasma processing chamber with a series of dielectric windows that project into the chamber, each of which contains a coil. Jeng does not show a ion source nor is it directed to the formation of an ion source.

Claim 2, as now amended, clearly distinguishes Jeng in that it is directed to an ion source, and recites an optical grid as part of the apparatus. Jeng does not show or suggest these features.

New independent claim 10 similarly recites an ion source including, inter alia, an optical grid, and thus clearly distinguishes the prior art of record.

Applicant is separately submitting to the Examiner an Information Disclosure Statement for the Examiner's consideration. Applicant requests the Examiner verify this IDS has been received and considered prior to further action on this application.

A petition for a two-month extension of time is attached hereto. If any petition for extension of time is necessary to accompany this communication, please consider this paper a petition for such an extension of time, and apply the appropriate extension of time fee to Deposit Account 23-3000. If any other charges or credits are necessary to complete this communication, please apply them to Deposit Account 23-3000.

Nov 28 05 10:58p Humphrey

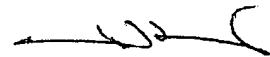
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